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To: Examiner Kevin V. Quinto	Total Pages Sent: 13
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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

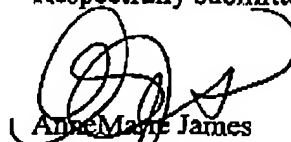
Applicant:	Cheng, et al.	Docket No.:	TSM03-0698
Serial No:	10/786,643	Art Unit:	2826
Date Filed:	February 25, 2004		
Title:	Method and Structure for CMOS Devices with Stress Relaxed by Ion Implantation of Carbon or Oxygen Containing Ions		

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- Certification of Facsimile Transmission (1 page)
- Amendment (12 pages)

Respectfully submitted,

  
AnneMarie James  
Legal Assistant

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Implantation of Carbon or Oxygen Containing Ions

Mail Stop: Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

The following amendments and remarks are presented in response to the Examiner's Office

Action mailed June 21, 2005. Please amend the above-referenced application as follows.